

APPLICATION DATA SHEET

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Publication Filing Type: new-utility

Attorney Docket Number: 740756-2447

Application Type: utility

Title of Invention: INSULATING FILM AND METHOD OF PRODUCING SEMICONDUCTOR DEVICE

Suggested Representative Figure: Fig. 1A

Customer Number Correspondence Address: 22204

22204

Continuity Data:

This application is a division of 09/466,828 1999-12-20 Pending

This application is a continuation of 09/190,828 1998-11-12 Issued

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This application is a continuation in part of 08/455,574 1995-05-31 Abandoned

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Foreign Priority:

5-55236 JP 1993-02-19 Priority Claimed

Assignee (Publish): SEMICONDUCTOR ENERGY LABORATORY CO., LTD.

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